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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

WATANABE, Kenichi

Group Art Unit: **2815**

Serial No.: **10/050,171**

Examiner: **WARREN, Matthew E.**

Filed: **January 18, 2002**

P.T.O. Confirmation No.: **7623**

FOR: **SEMICONDUCTOR DEVICE CAPABLE OF SUPPRESSING
CURRENT CONCENTRATION IN PAD AND ITS MANUFACTURE
METHOD**

AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. 1.312

MAIL STOP IF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 4, 2007

Sir:

Applicants received a Notice of Allowance dated **April 4, 2007** in connection with the above-identified application. It is respectfully requested that the following amendment be made to the specification of this application:

Amendments to the specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.